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Substitute for form 1449B/PTO Complete if Known Application Number 10/561,775 Filing Date INFORMATION DISCLOSURE 12/20/2005 STATEMENT BY APPLICANT First Named Inventor Anatoli N. Verentchikov Art Unit 2800 (Use as many sheets as necessary) Examiner Name Sheet Attorney Docket Number 1 2 LEC01 P-432

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		BENJAMIN M. CHIEN, ET AL., "Plasma Source Atmospheric Pressure Ionization Detection of Liquid Injection Using an Ion Trap Storage/Reflectron Time-of-flight Mass Spectromerty," Anal. Chem. 1993, 65, 1916-1924.	
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		H. WOLLNIK, A. CASARES, "An Anergy-isochronous Multi-pass TOF MS Consisting of Two Coaxial Electrostatic Mirrors," International Journal of Mass Spectrometry 227 (2003) pp. 217-222.	

i	Data	
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STATEMENT BY APPLICANT				First Named Inventor	Anatoli N. Verentchikov		
				Art Unit	2800		
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Sheet	2	of	2	Attorney Docket Number	LEC01 P-432		

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		H. WOLLNIK, "Mass Separators," Nuclear Instruments and Methods in Physics Research, A 258, (1987) pp. 289-296.		
		H. WOLLNIK, "Time-of-Flight Mass Analyzers," Mass Spectromery Reviews, 1993, 12, 89-114, John Wiley & Sons.		
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